

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Ino et al.

ATTORNEY DOCKET NO: *S. Steven* *2/9* *4/20/*

09792909-4645

SERIAL NO.

GROUP ART UNIT:

FILING DATE:

EXAMINER:

INVENTION: "PROCESS OF FABRICATING THIN
FILM SEMICONDUCTOR DEVICE"

which is a Divisional of copending Application of the following U.S. Application

APPLICANT: Ino et al.

OLD ATTORNEY DOCKET NO:

P97,0916

NEW ATTORNEY DOCKET NO:

09792909-3529

SERIAL NO. 08/878,588

GROUP ART UNIT: 2823

FILING DATE: June 19, 1997

EXAMINER: S. Hawranek

INVENTION: "PROCESS OF FABRICATING THIN
FILM SEMICONDUCTOR DEVICE"

PRELIMINARY AMENDMENT

Asst. Commissioner of Patents
Washington, D.C. 20231

Sir:

Please enter the following amendment prior to examination of the above-identified patent application.

IN THE SPECIFICATION

Between the title and the heading "Background of the Invention" insert the following:

--RELATED APPLICATION DATA

This application is a divisional of copending application Serial No. 08/878,588 filed June 19, 1997, New Attorney Docket No. 09792909-3529, Old Attorney Docket No. P97,0916. The present and foregoing applications claim priority to Japanese application No.